

PTO/SB/08A (08-03)
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Complete if Known Substitute for form 1449A/PTO **Application Number** 10/049,672 INFORMATION DISCLOSURE Filing Date 4/30/2002 STATEMENT BY APPLICANT First Named Inventor KURATA, et al. Art Unit 1765 Examiner Name Duy Vu Nguyen Deo Sheet of Attorney Docket Number 1204.41191X00

			U.S. PATENT	OCUMENTS	
Examiner Initials	Cite No.1	Oocument Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		FOREIC	N PATENT DO	UMENTS		
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/DD/		EP 0 896 042 A1	2-10-1999	Cabot Corporation		
/DD/		WO 98/18159	4-30-1998	Micron Technology, Inc.		
/DD	1	EP 0 649 168 A2	4-19-1995	Nippon Steel Corporation		
/DD/		EP 0 913 442 A2	5-6-1999	Hitachi, Ltd.		
/DD/		WO 99/64527 A1	12-16-1999	Rodel Holdings, Inc.		
/DD/		EP 1 125 999 A1	8-22-2001	Fujimi Incorporated		
/DD/		WO 01/83638 A1	11-8-2001	Advanced Technology Materials, Inc.		

Examiner Signature	/Duy Vu Deo/ (09/17/2007)	Date Considered

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Substitute for form 1449/PTO				Complete if Known		
				Application Number	10/049,672	
INFORMATION DISCLOSURE				Filing Date	4/30/2002	
STATEMENT BY APPLICANT			PLICANT	First Named Inventor	KURATA, et al.	
				Group Art Unit	1765	
(use as many sheets as necessary)			essary)	Examiner Name	Duy Vu Nguyen Deo	
Sheet	2	of	2	Attorney Docket Number	1204.41191X00	

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Initials*	Cite No.	item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s),	T
/DD/		Wang, et al., "Effects of corrosion environments on the surface finishing of copper chemical mechanical polishing", Preparation and Characterization, vol. 308-309, October 31, 1997, pgs, 518-522	
/DD/		Supplementary European Search Report dated February 27, 2007, for Application No. 00953466.0 – 1235 PCT/JP0005508	1
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